



Imole

Patent
Attorney Docket No. 015290-504

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Ni, Tuqiang et. al.

Application No.: 09/883,207

Filing Date: June 19, 2001

Title: Plasma Etching of Dielectric Layer With Etch Profile Control

Group Art Unit: 1765

Examiner: DEO, DUY VU NGUYEN

Confirmation No.: 9862

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please advise, in writing, as to the current status of the above-captioned application.

The issue fee was paid on December 5, 2003 and the undersigned has yet to receive an Issue Notification.


Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

P.O. Box 1404
Alexandria, Virginia 22313-1404
(703) 836-6620

Date: April 5, 2004

By


Peter K. Skiff
Registration No. 31,917